

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re U.S. Patent Application )  
 )  
Applicant: Hiroshi JIKEN, Yuuichi NASU )  
 and Takeshi MASUDA )  
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Serial No.: NOT YET AVAILABLE )  
 )  
Filed: September 23, 2005 )  
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For: SEMICONDUCTOR EPITAXIAL WAFER )  
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Examiner: NOT YET AVAILABLE )  
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Art Unit: NOT YET AVAILABLE )  
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INFORMATION DISCLOSURE STATEMENT

Mail Stop PCT  
Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Pursuant to 37 C.F.R. §1.97, a list of documents is disclosed on the attached Form PTO-1449 that may be material to the examination of this application. The listed Documents are enclosed herewith.

No inferences should be drawn that the attached list represents a comprehensive investigation, or that any material disclosed is equivalent to the subject invention. In addition, none of the documents that have publication dates prior to the priority date of the above application anticipate the invention in this application.

The cited document(s) disclose numerous specific features. There has been no attempt to list each and every feature disclosed by each document. The Examiner is requested to review the document(s) and determine the extent of the materiality of the document disclosures with respect to the present invention.

Applicant also encloses a translation of the Japanese PCT Search Report citing two (2) of these references.

The discussion of any art and the citation of any document(s) herein is not to be construed as an admission that the art or document disclosure is necessarily within the invention field of endeavor, that the art or document disclosure is necessarily prior in time to a particular date which may be relevant to the instant patent application, and/or that the art or document disclosure is otherwise necessarily prior art as defined by the patent law with respect to the instant invention and application.

Also, there is reserved the right to later set forth how the instant invention is distinguished over the disclosure of any document or other art, including the disclosures of the art and document(s) recited herein, that may be cited by the Examiner in rejecting a claim in the instant patent application. The recitation herein of the art and document(s) is not to be construed as an assertion that more pertinent art could not possibly be in existence.

Respectfully submitted,  
**WELSH & KATZ, LTD.**



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Dated: September 23, 2005

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<b>INFORMATION DISCLOSURE CITATION</b> <i>(Use several sheets if necessary)</i>				Docket Number (Optional) 1110/95342-PCT		Application Number <b>NOT YET AVAILABLE</b>		
				Applicant(s) <b>Hiroshi JIKEN, Yuuichi NASU and Takeshi MASUDA</b>				
				Filing Date <b>September 23, 2005</b>		Group Art Unit <b>NOT YET AVAILABLE</b>		
<b>U.S. PATENT DOCUMENTS</b>								
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
<b>U.S. PATENT APPLICATION PUBLICATIONS</b>								
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
<b>FOREIGN PATENT DOCUMENTS</b>								
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
		JP 7-37893 A	2/7/1995	JAPAN				
		JP 3-159151 A	7/9/1991	JAPAN				
		JP 10-303207	11/13/1998	JAPAN				
<b>OTHER DOCUMENTS</b> <i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>								
<b>EXAMINER</b> <hr/> <b>EXAMINER:</b> Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.				<b>DATE CONSIDERED</b> <hr/>				